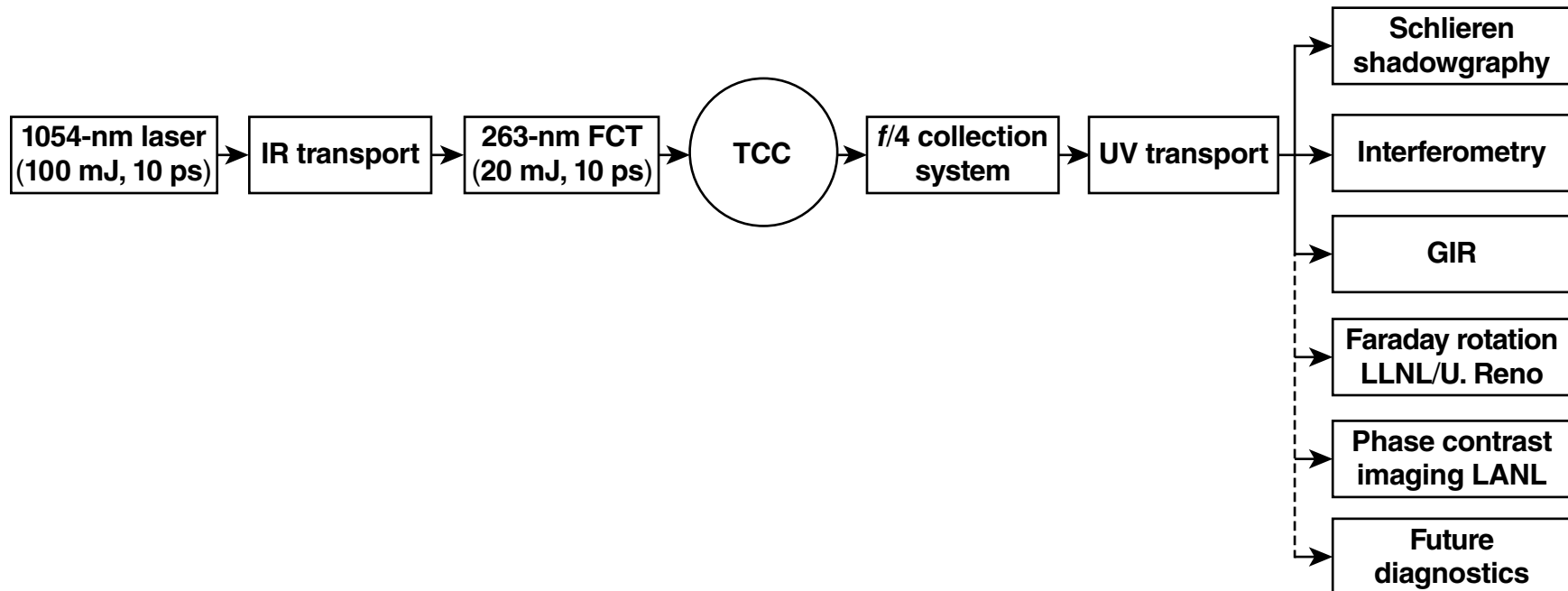


The OMEGA EP 4ω Probe Diagnostic

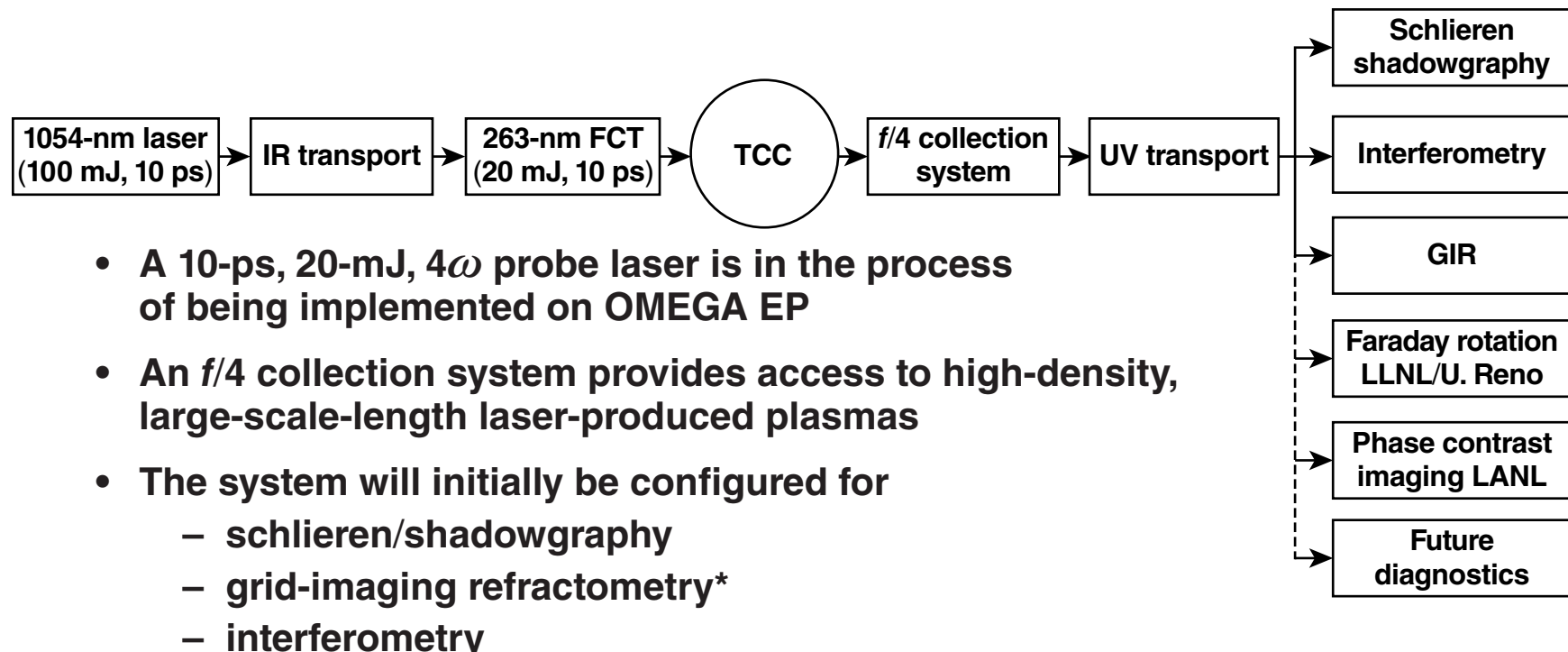


D. H. Froula
University of Rochester
Laboratory for Laser Energetics

Omega Laser Facility
Users' Group Workshop
Rochester, NY
27–29 April 2011

Summary

The 4ω diagnostic on OMEGA EP will be activated by the end of FY11 and be ready for users by January 2012



- A 10-ps, 20-mJ, 4ω probe laser is in the process of being implemented on OMEGA EP
- An $f/4$ collection system provides access to high-density, large-scale-length laser-produced plasmas
- The system will initially be configured for
 - schlieren/shadowgraphy
 - grid-imaging refractometry*
 - interferometry
- Design presents options for expanded optical diagnostics
- Advanced optical-design tools are being adapted to provide synthetic diagnostic images for experimental setup and analysis

The three diagnostics coupled with detailed optical modeling of the system will provide a novel diagnostic platform for detailed plasma measurements.

The 4 ω team



W. Theobald

C. Stoeckl

R. S. Craxton

W. Seka

S. Ivancic (UR-Graduate Student)

M. Rushford (LLNL)

N. Kugland (LLNL-Post Doc)

B. Boni

D. Weiner

R. Jungquist

F. Ehrne

M. Bedzyk

M. J. Shoup III

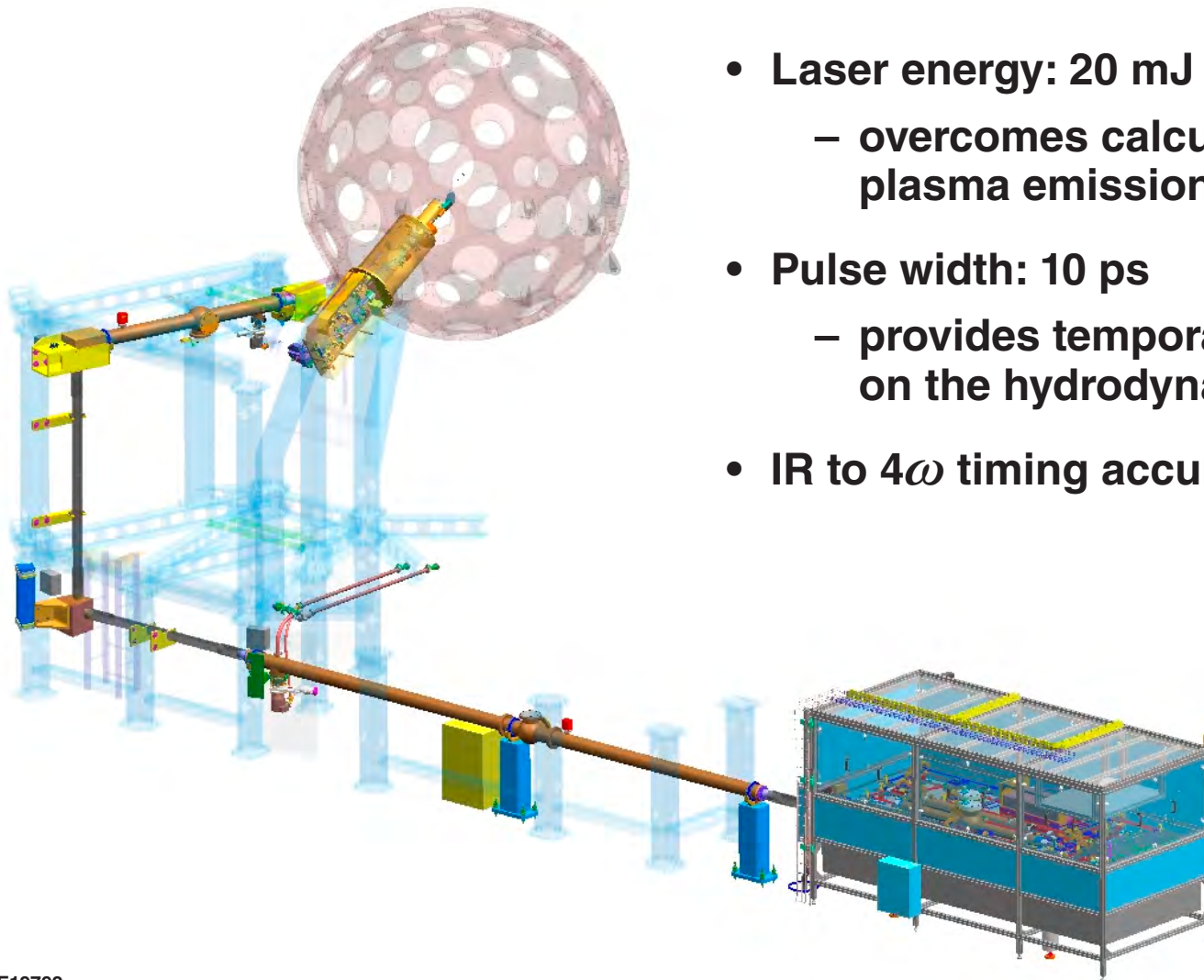
T. Duffy

J. Puth

R. Brown

R. G. Roides

A 263-nm (4ω) laser is currently being qualified on OMEGA EP and will be operational this summer

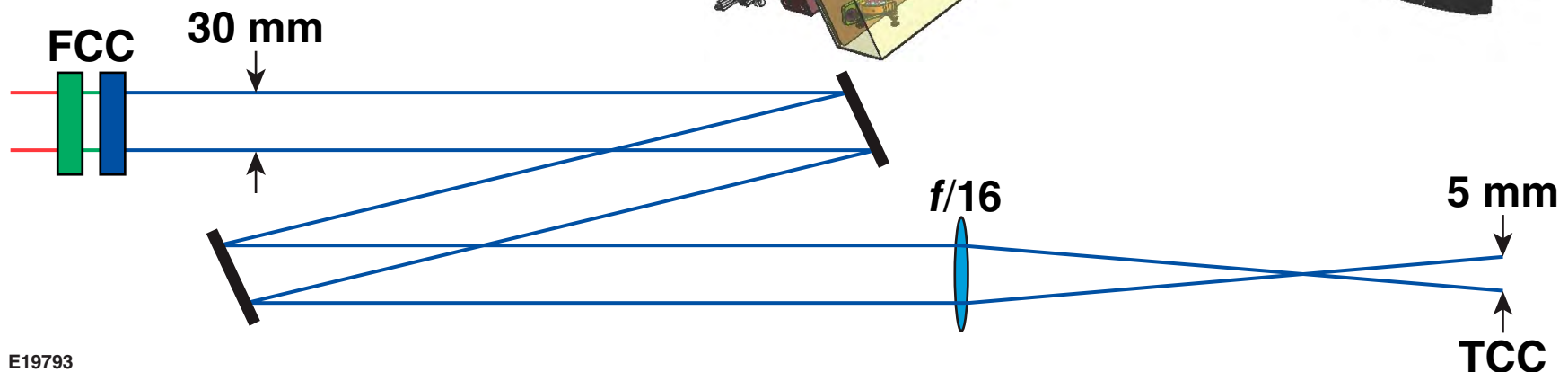
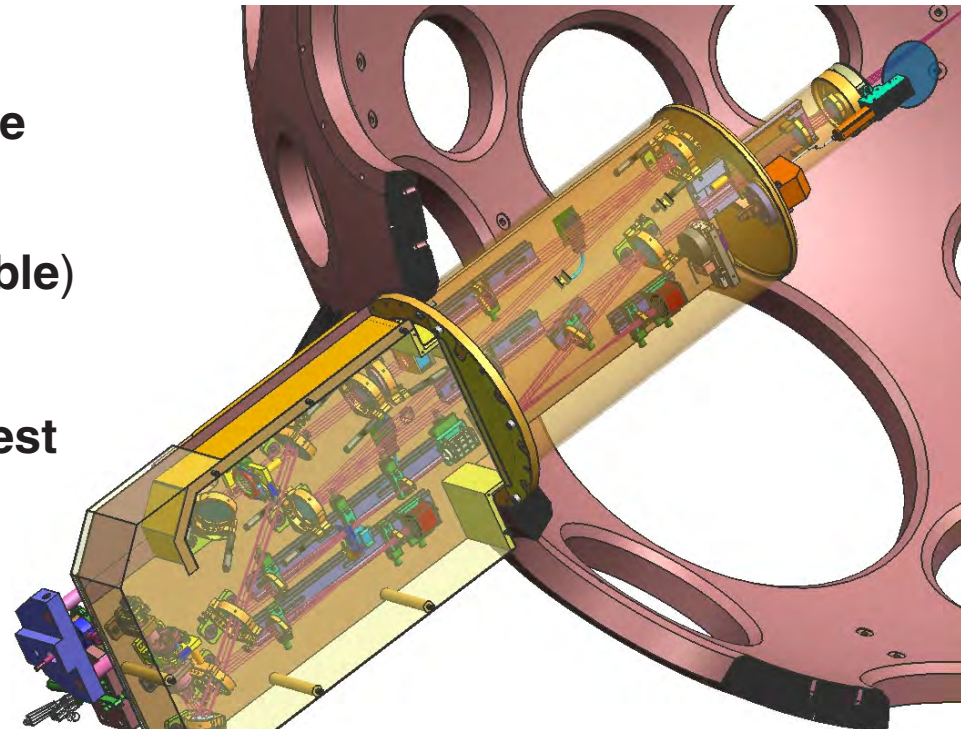


- Laser energy: 20 mJ at 4ω
 - overcomes calculated background plasma emission around 263 nm
- Pulse width: 10 ps
 - provides temporal resolution on the hydrodynamic time scales
- IR to 4ω timing accuracy: 10 ps

The laser system will deliver a 5-mm spot to target chamber center with high spatial uniformity



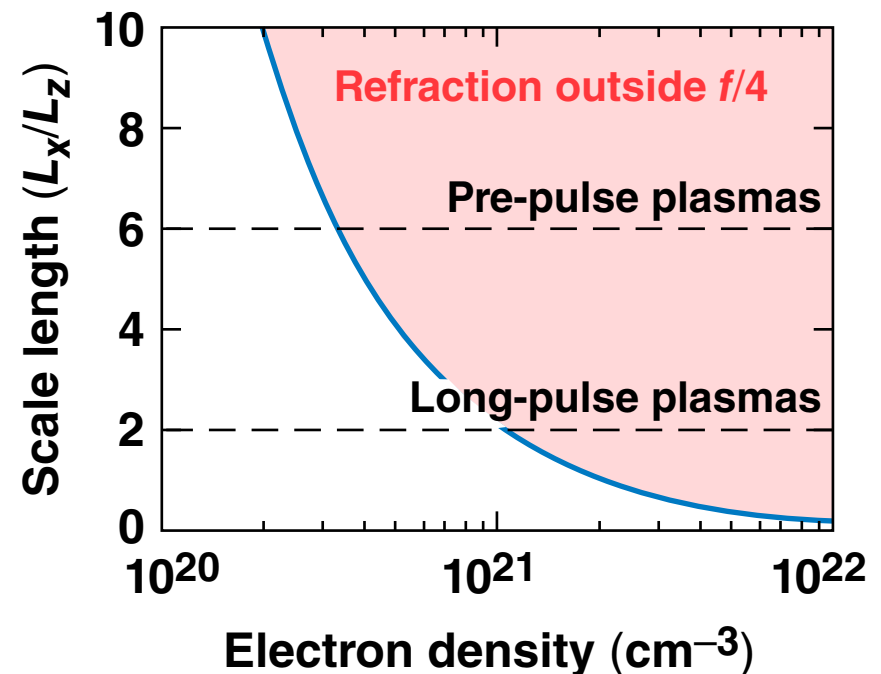
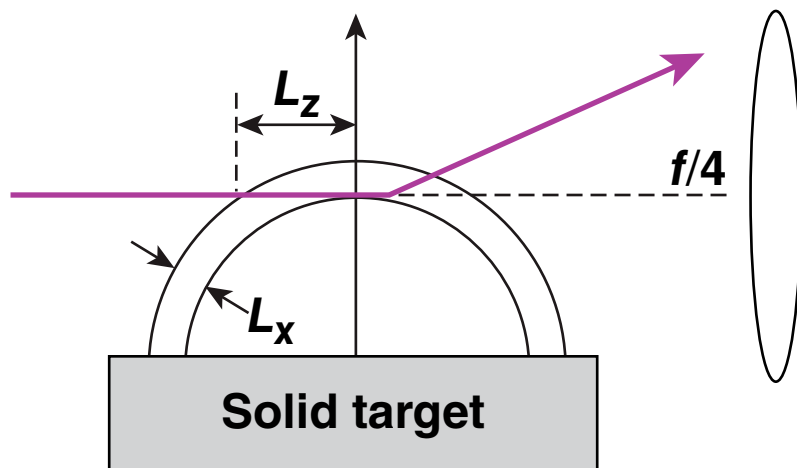
- High-quality spatial-beam profile
 - <20% modulation at TCC
- Polarization is controlled (variable)
- System can be focused at TCC
- Enters from port 71 chamber west



The optical collection system will provide access to high density laser-produced plasmas

An $f/4$ system:

- long-pulse plasmas ($L_x/L_z \sim 2$): $n_e = 10^{21} \text{ cm}^{-3}$
- prepulse plasmas ($L_x/L_z \sim 6$): $n_e = 4 \times 10^{20} \text{ cm}^{-3}$

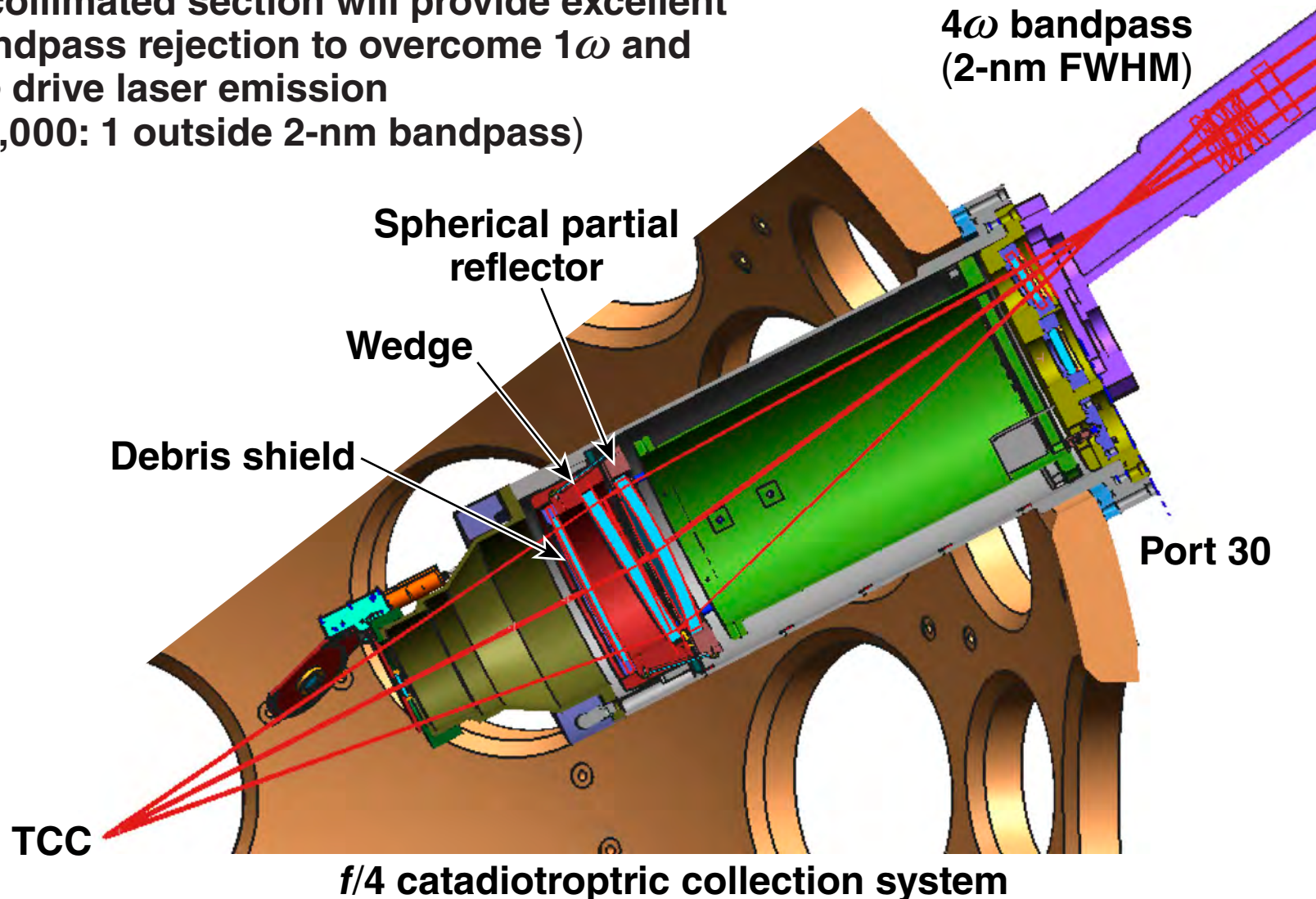


An $f/4$ system will provide access to highly refractive plasmas.

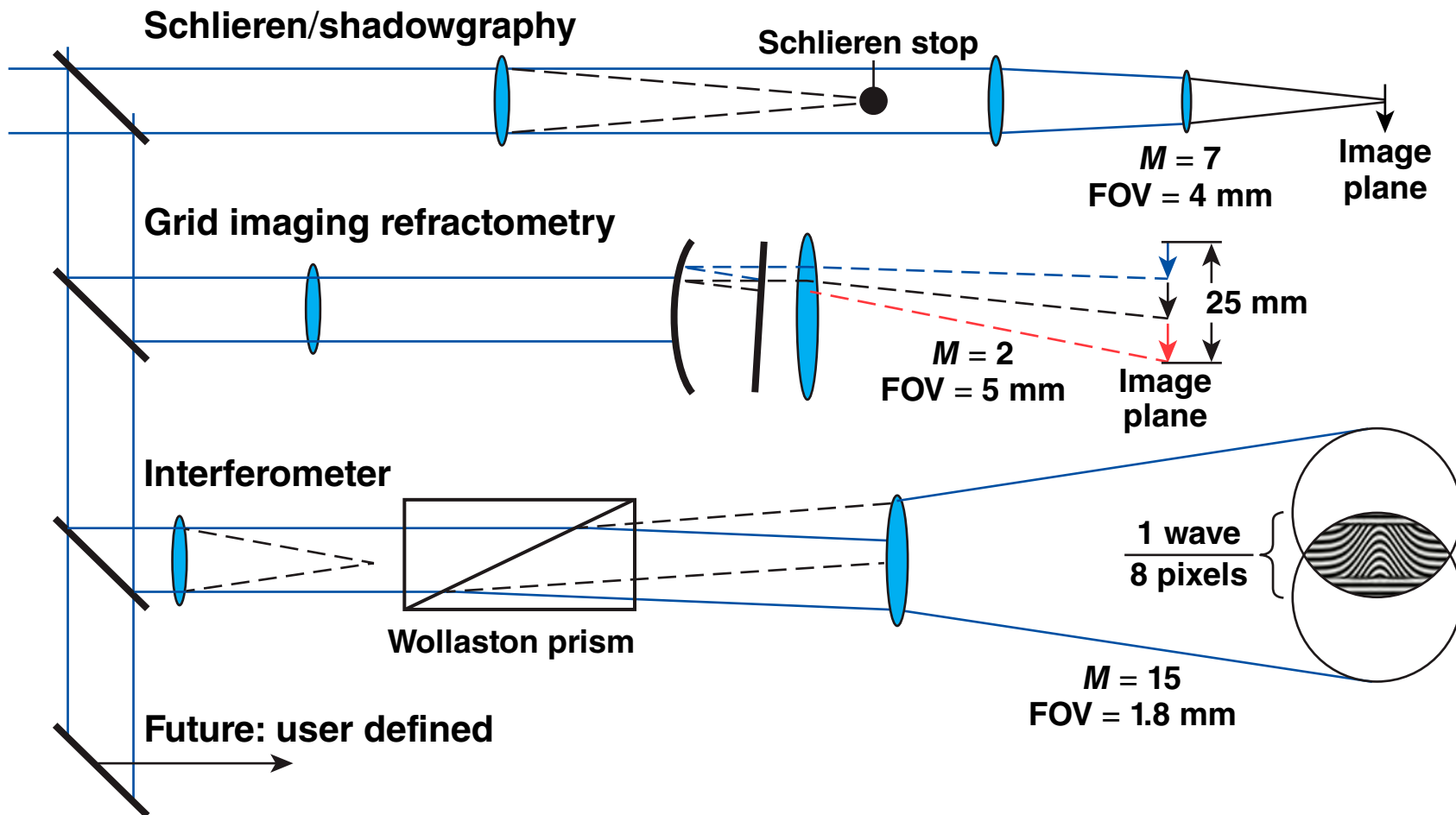
The $f/4$ collection system will provide $<5\ \mu\text{m}$ resolution over the 5-mm field of view



- A collimated section will provide excellent bandpass rejection to overcome 1ω and 3ω drive laser emission (10,000: 1 outside 2-nm bandpass)



The optical transport accommodates multiple diagnostics and has built-in flexibility

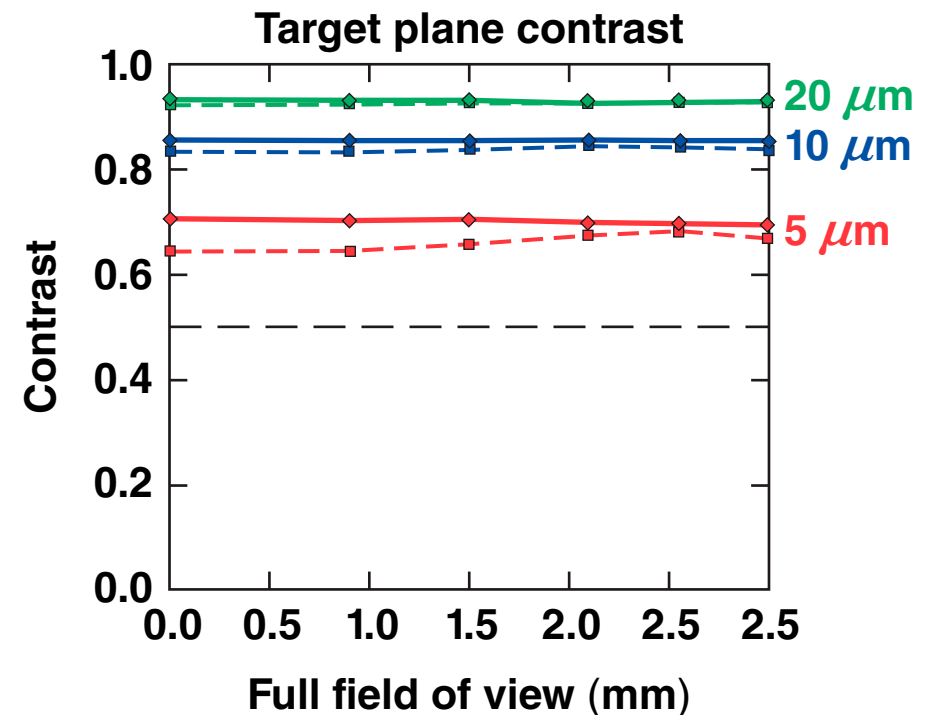
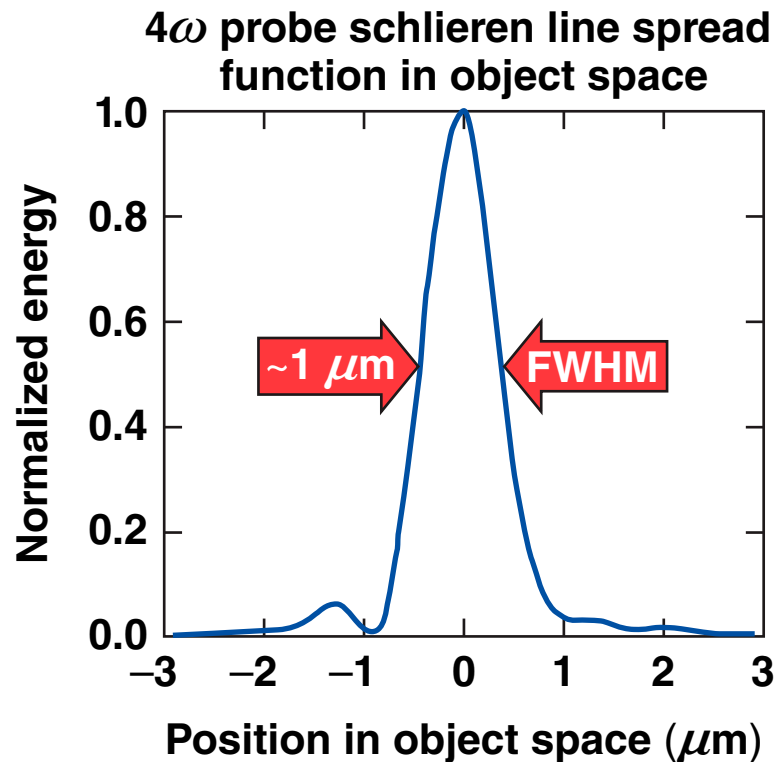


The 55-sq-ft diagnostic table provides space for diagnostic expansion.

Modeling indicates the schlieren optical design can produce 1- μm resolution in the plasma plane



- Convolved with the CCD pixels and alignment realities, a $<10\text{-}\mu\text{m}$ resolution is anticipated
- A magnification of $M = 7$ provides a $\sim 2.5\text{-mm}$ field of view

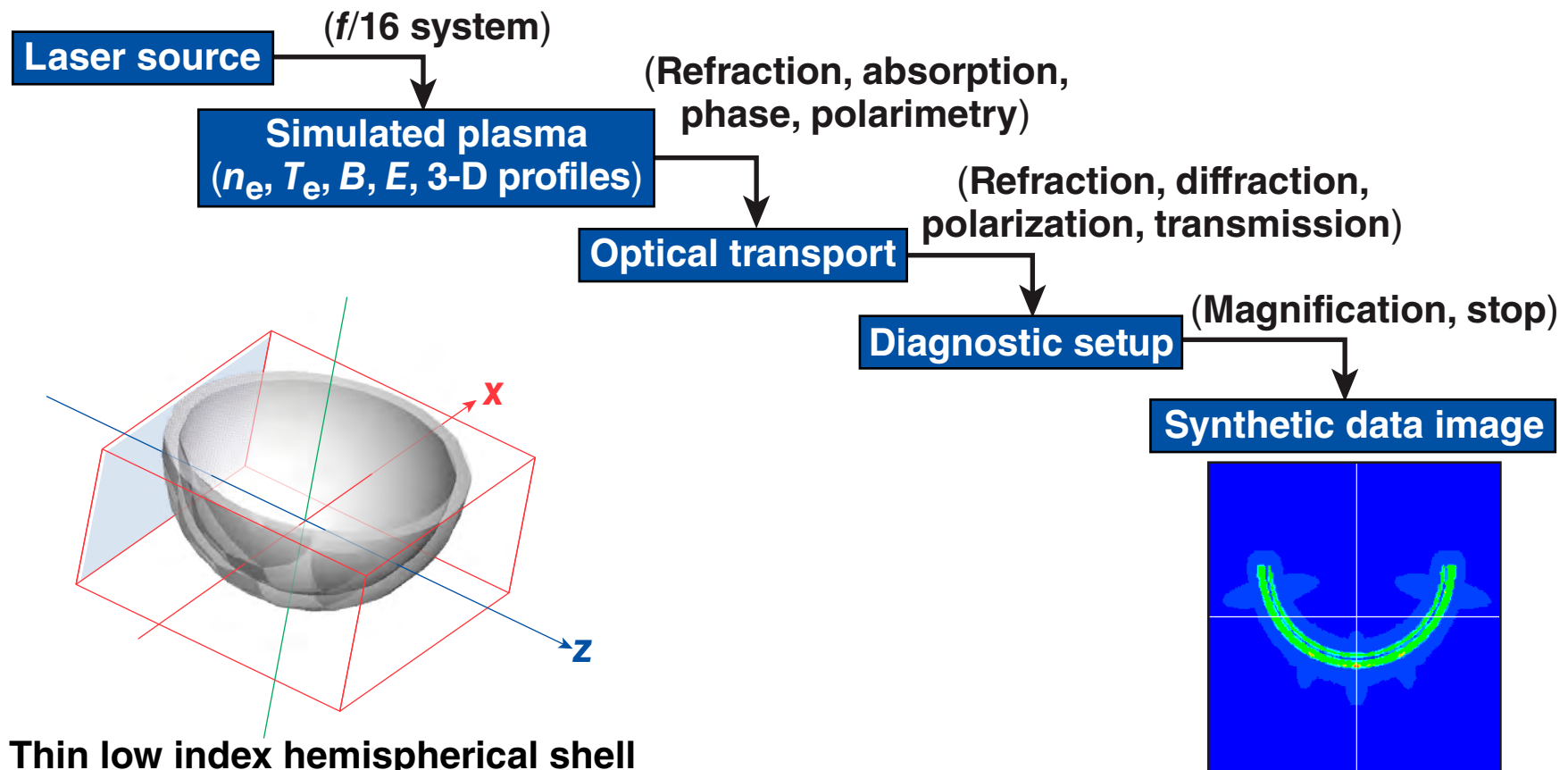


The system is designed to produce high resolution over the 2.5-mm field of view.

A complete analysis package is being developed to provide experimental design and complex data reduction



An optical transport model is being developed to propagate a complex optical-vector field through the complete system



This infrastructure will be available for experimental planning, data analysis, and advanced diagnostic design.

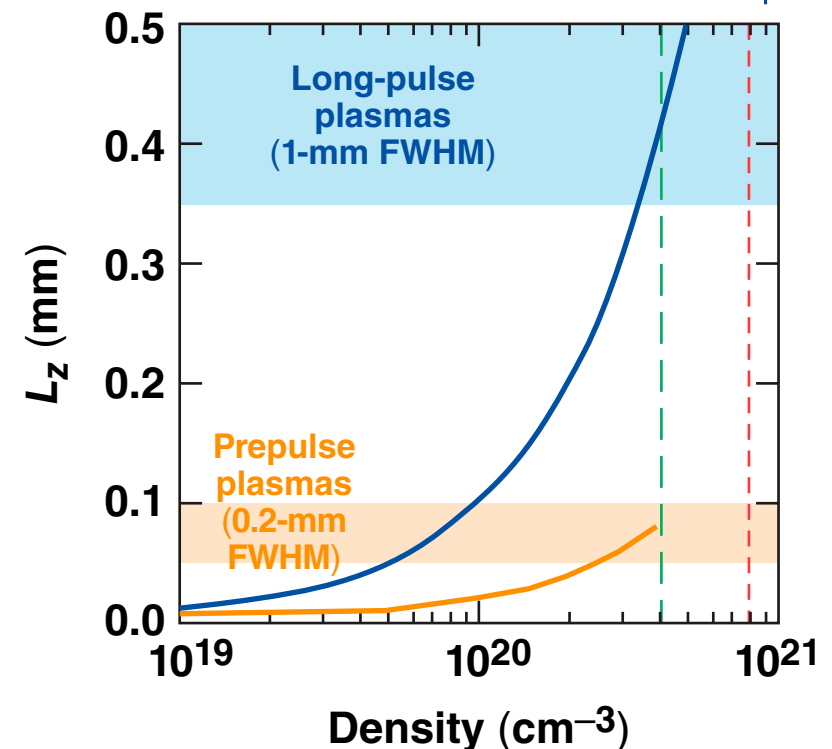
Interferometry is limited to electron densities below $\sim 4 \times 10^{20} \text{ cm}^{-3}$ in laser-produced plasmas



- Interferometry has been designed for 5- μm resolution
- A magnification of 15 provides a 1.8-mm field of view

Experimental design considerations

- Probe beam must overlap plasma with vacuum
- Polarization will be rotated to align fringes with experimental configuration
- Scale lengths (L_x, L_z) limit the maximum accessible density



$$\left| \frac{\nabla \phi(x, z)}{2\pi} \right|_{\max} < \frac{1 \text{ wave}}{8 \text{ pixels}}$$

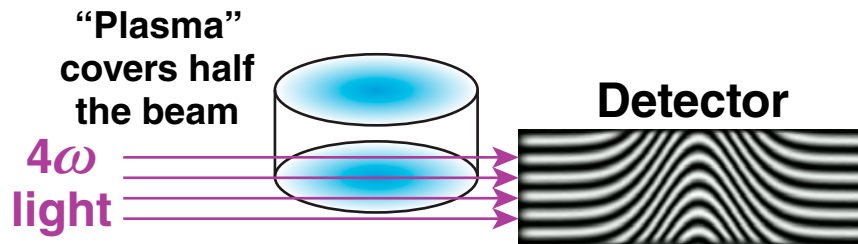
$$\left| \frac{\nabla \phi(x)}{2\pi} \right|_{x=\frac{w}{2}} = \frac{\sqrt{\pi \ell n(2)}}{2\lambda} \left(\frac{n_{e,0}}{n_{cr}} \right) < \frac{1}{8 \text{ pixels}} \longrightarrow n_{e,0} < 7 \times 10^{20} \text{ cm}^{-3}$$

$$\left| \frac{\nabla \phi(z)}{2\pi} \right|_{x=0, y=0} = \frac{\sigma \sqrt{\pi}}{2\lambda} \left(\frac{n_{e,0}}{n_{cr}} \right) \left(\frac{1}{L_z} \right) < \frac{1}{8 \text{ pixels}} \longrightarrow n_{e,0} < 4 \times 10^{20} \text{ cm}^{-3}$$

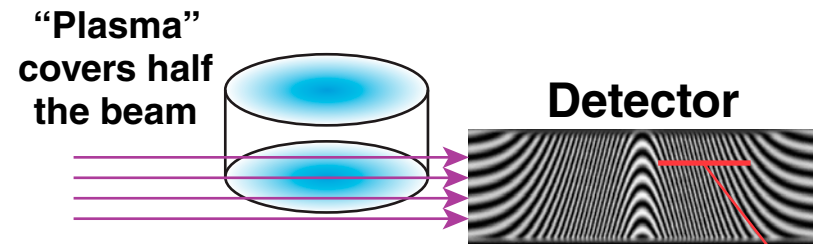
Optical modeling can be used to optimize experimental design and identify limitations



Plasma Gaussian $n_e(x, y)$
Uniform $n_e(z)$
FWHM $w = 0.2$ mm
 $n_{e,0} = 2.0 \times 10^{20} \text{ cm}^{-3}$

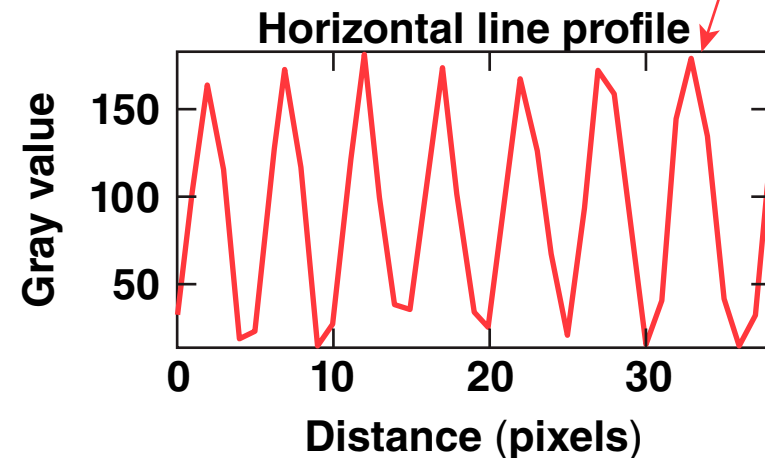


Plasma Gaussian $n_e(x, y)$
Uniform $n_e(z)$
FWHM $w = 0.2$ mm
 $n_{e,0} = 8.0 \times 10^{20} \text{ cm}^{-3}$



Optical model

- Used to identify diagnostic limitations
- Used to optimize experimental design
- Used for advanced post-shot analysis
 - optical model includes refraction

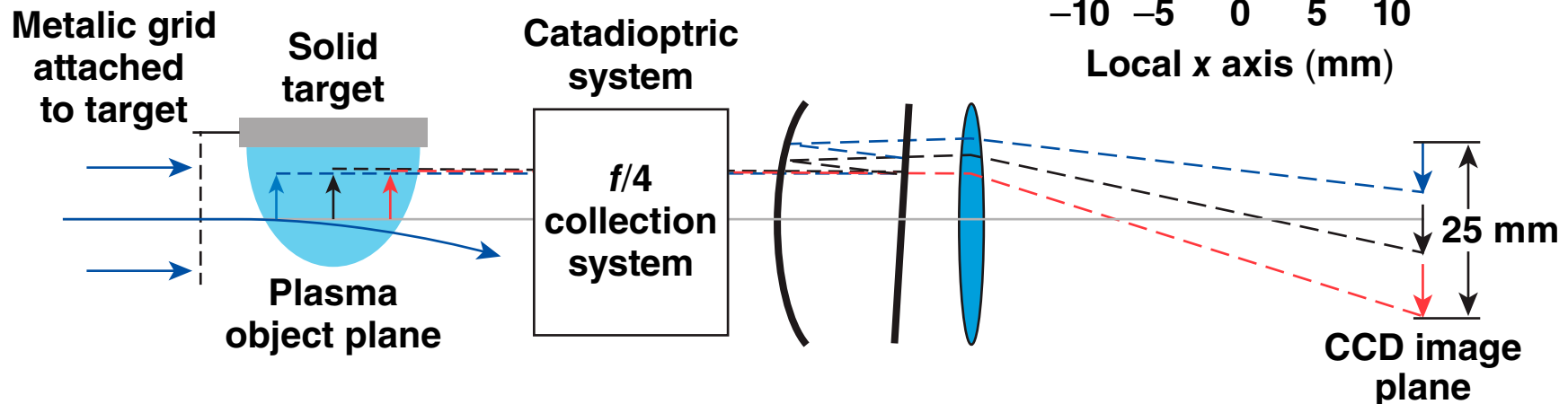
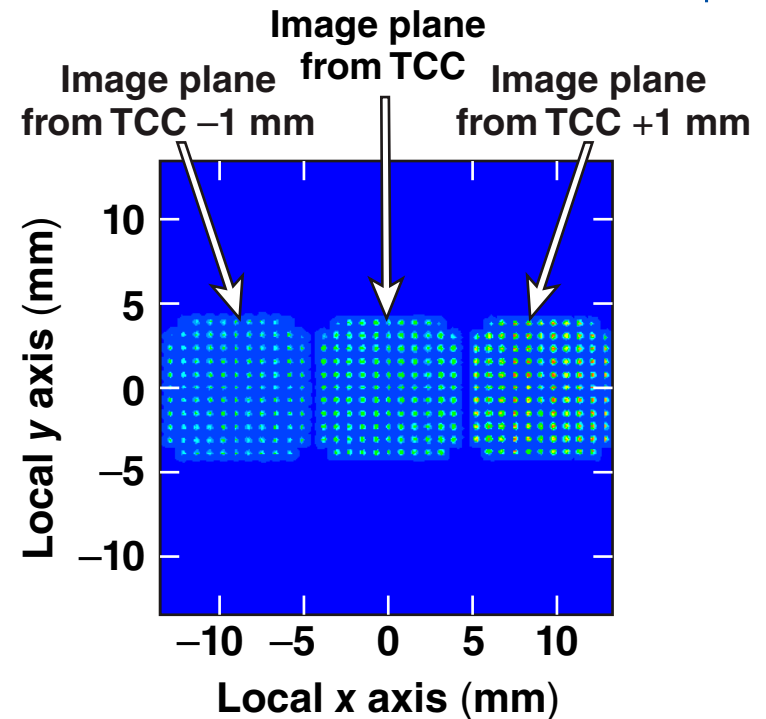


Danger zone:
close to the sampling limit!

Grid-imaging refractometry (GIR) measures the refraction of beamlets at three locations within the plasma

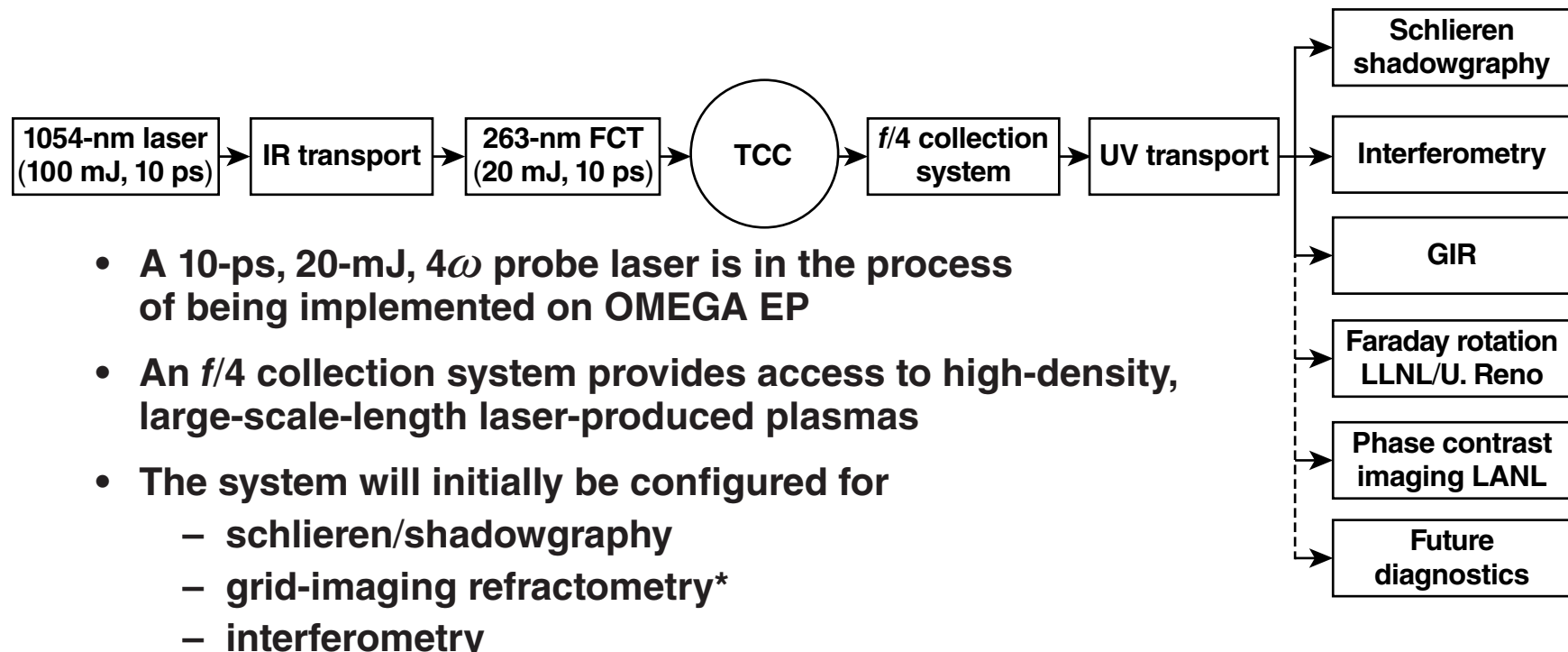


- GIR extends the density measurements to 10^{21} cm^{-3} in long-scale-length plasmas
- Three longitudinal objects in the plasma are imaged to a single CCD
- The system is designed to have $<50\text{-}\mu\text{m}$ resolution over a 5-mm field of view
- Magnification of 2



Summary/Conclusions

The 4ω diagnostic on OMEGA EP will be activated by the end of FY11 and be ready for users by January 2012



- A 10-ps, 20-mJ, 4ω probe laser is in the process of being implemented on OMEGA EP
- An $f/4$ collection system provides access to high-density, large-scale-length laser-produced plasmas
- The system will initially be configured for
 - schlieren/shadowgraphy
 - grid-imaging refractometry*
 - interferometry
- Design presents options for expanded optical diagnostics
- Advanced optical-design tools are being adapted to provide synthetic diagnostic images for experimental setup and analysis

The three diagnostics coupled with detailed optical modeling of the system will provide a novel diagnostic platform for detailed plasma measurements.